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I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Dated: January 25, 2005

Signature:

(Michael R. Hull)

Docket No.: 29936/39510
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Young Hee Mun et al.

Application No.: 10/699,438

Filed: October 31, 2003

For: SILICON WAFERS AND METHOD OF
FABRICATING THE SAME



Confirmation No.: 3273

Art Unit: 2824

Examiner: Michael Lebentritt

RESPONSE TO RESTRICTION REQUIREMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the restriction requirement set forth in the office action mailed on December 27, 2004, applicants hereby elect Group 1, claims 1-13 for continued examination, with traverse.

The Commissioner is authorized to charge any fee deficiency required by this paper, or credit any overpayment, to Deposit Account No. 13-2855.

Dated: January 25, 2005

Respectfully submitted,

By _____
Michael R. Hull

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